

Notice of References Cited	Application/Control No. 10/521,258	Applicant(s)/Patent Under Reexamination VAN GEMERT, LEONARDUS AN	
	Examiner ALBERT H. CUTLER	Art Unit 2622	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,384,397	05-2002	Takiar et al.	250/208.1
*	B	US-5,821,532	10-1998	Beaman et al.	250/239
*	C	US-2002/0097453	07-2002	Chen, Wen-Ching	358/509
*	D	US-7,009,654	03-2006	Kuno et al.	348/374
*	E	US-6,693,674	02-2004	Wataya et al.	348/373
*	F	US-5,359,190	10-1994	O'Regan et al.	250/216
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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